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APPLICATION NO. FILING DATE ATTORNEY DOCKET NO. CONFIRMATION NO. FIRST NAMED INVENTOR 10/078,766 02/19/2002 Takeshi Miura 51380 4845 **EXAMINER** 21874 7590 03/25/2005 **EDWARDS & ANGELL, LLP** LEADER, WILLIAM T P.O. BOX 55874 ART UNIT PAPER NUMBER BOSTON, MA 02205 1742

DATE MAILED: 03/25/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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·	Application No.	Applicant(s)	
	10/078,766	MIURA ET AL.	
Office Action Summary	Examiner	Art Unit	
	William T. Leader	1742	
The MAILING DATE of this communication a	appears on the cover sheet w	ith the correspondence address	
Period for Reply	DIVIO OFT TO EVOIDE AM	ONTHIO) FROM	
A SHORTENED STATUTORY PERIOD FOR REI THE MAILING DATE OF THIS COMMUNICATION - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication If the period for reply specified above is less than thirty (30) days, a second of the period for reply is specified above, the maximum statutory perion of the period for reply within the set or extended period for reply will, by stated and parent term adjustment. See 37 CFR 1.704(b).	N. 1.136(a). In no event, however, may a reply within the statutory minimum of thir iod will apply and will expire SIX (6) MON tute, cause the application to become Al	reply be timely filed by (30) days will be considered timely. ITHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on 16	6 February 2005.		
2a) ☐ This action is FINAL . 2b) ☑ T	his action is non-final.		
3) Since this application is in condition for allow	wance except for formal matt	ers, prosecution as to the merits is	
closed in accordance with the practice unde	er <i>Ex par</i> te <i>Quayle</i> , 1935 C.D). 11, 453 O.G. 213.	
Disposition of Claims	•		
•	nlication		
4)⊠ Claim(s) <u>5 and 7-11</u> is/are pending in the ap 4a) Of the above claim(s) is/are withd			
5) Claim(s) is/are allowed.			
6)⊠ Claim(s) <u>5 and 7-11</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and	d/or election requirement.		
Application Papers			
9) The specification is objected to by the Exam	iner		
10) The drawing(s) filed on is/are: a) a		by the Examiner	
Applicant may not request that any objection to t			
Replacement drawing sheet(s) including the corr			
11) The oath or declaration is objected to by the			
Dui - uitu			
Priority under 35 U.S.C. § 119			
 12) Acknowledgment is made of a claim for fore a) All b) Some * c) None of: 1. Certified copies of the priority document 		§ 119(a)-(d) or (f).	
2. Certified copies of the priority docume	ents have been received in A	application No	
3. Copies of the certified copies of the p	riority documents have been	received in this National Stage	
application from the International Bur	eau (PCT Rule 17.2(a)).		
* See the attached detailed Office action for a l	list of the certified copies not	received.	
Attachment/c\			
Attachment(s) 1) Notice of References Cited (PTO-892)	4\ \ Interview 5	Summary (PTO-413)	
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail Date	
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/Paper No(s)/Mail Date	708) 5) Notice of I 6) Other:	nformal Patent Application (PTO-152)	

Application/Control Number: 10/078,766 Page 2

Art Unit: 1742

DETAILED ACTION

- 1. A request for continued examination under 37 CFR 1.114 was filed in this application after appeal to the Board of Patent Appeals and Interferences, but prior to a decision on the appeal. Since this application is eligible for continued examination under 37 CFR 1.114 and the fee set forth in 37 CFR 1.17(e) has been timely paid, the appeal has been withdrawn pursuant to 37 CFR 1.114 and prosecution in this application has been reopened pursuant to 37 CFR 1.114. Applicant's submission filed on February 16, 2005 has been entered.
- 2. Claims 5 and 7-11 are pending.
- 3. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claim Rejections - 35 USC § 102

- 4. Claims 5 and 7-11 are rejected under 35 U.S.C. 102(e) as being anticipated by Nagai et al (6,709,563).
- 5. As indicated in the previous office action, the Nagai et al patent is directed to a copper-plating bath that is suitable for use in electrodepositing copper to form interconnects, including a trench, on a semiconductor wafer. See Figs. 39A-39C and column 1, lines 31-40. The plating bath should include a complexing agent which can improve plating uniformity (column 2, lines 36-42). The pH of the plating bath

1

may be maintained with a range of 7-14 (column 2, lines 57-60. This range overlaps and anticipates applicant's range as recited in instant claim 5 at pH values of 7-8.4.

- 6. Nagai et al disclose a number of suitable complexing agents. These include ethylenediamine tetramethylene phosphonic acid and diethylenetriamine pentamethylene phosphonic acid (column 3, lines 22-31). This portion of the Nagai et al patent teaches the limitations of claims 5, 7, 9 and 10.
- 7. Nagai et al further discloses that the copper-plating bath can be used in plating over an outer seed layer to reinforce the thin portion of the seed layer. See the abstract. This portion of Nagai et al teaches the limitation recited in instant claims 8 and 11.

Claim Rejections - 35 USC § 103

- 8. Claims 5 and 9-11 are rejected under 35 U.S.C. 103(a) as being unpatentable over Krishnamoorthy et al (6,319,387) in view of Florio et al (5,858,198).
- 9. The Krishnamoorthy et al patent is directed to a copper alloy electroplating bath for microelectronic applications. One known method for forming interconnects is the dual damascene process in which trenches and vias are formed by etching in a dielectric layer on the semiconductor wafer. Barrier and seed layers are formed and copper is deposited to fill the openings. See column 2, lines 43-67. Krishnamoorthy

et al disclose the use of a copper electroplating bath containing a minor amount of alloying metal. Table 1 (column 7) lists a preferred electroplating solution. The solution contains ED or EDTA which serves as a complexing agent and has a pH of about 8 to 11. The inclusion of complexing agents is also disclosed at column 6, lines 48-53. The disclosed pH range overlaps and anticipates applicant's range as recited in instant claim 5 at pH values of 8.0-8.4.

Page 4

10. Claims 5 and 7-11 differ from Krishnamoorthy et al by reciting particular complexing agents. The Florio et al patent is directed to an electroplating process. In a part of the process a solution containing copper complexing agents is used. Suitable copper complexing agents include ethylenediamine tetraacetic acid (EDTA) and triethanolamine (column 8, lines 38-58). The prior art of record is indicative of the level of skill of one of ordinary skill in the art. It would have been obvious to have utilized triethanolamine as a copper complexing agent in the process of Krishnamoorthy et al because triethanolamine and EDTA are taught to be equivalents by Florio et al.

Response to Amendment

11. Applicant's Remarks have been carefully considered but are not deemed to be persuasive. At page 4 of the Remarks, applicant indicates that a Rule 131

Application/Control Number: 10/078,766

Art Unit: 1742

Declaration is being submitted under separate cover which will antedate the Nagai et al patent. To date, this Declaration has not been incorporated into the file.

12. Applicant argues that there is no incentive to utilize a component of a carbonaceous dispersion that is utilized on a printed circuit board in a copper plating composition. This argument is not convincing. Krishnamoorthy et al disclose the use of a copper electroplating bath containing ED or EDTA which serves as a complexing agent. Florio discloses that copper complexing agents include ethylenediamine tetraacetic acid (EDTA) and triethanolamine. Thus, Florio suggests the equivalence of EDTA and triethanolamine as copper complexing agents. In view of this teaching, one of ordinary skill in the art would be led to use one in place of another. Thus, the substitution of triethanolamine for EDTA in the process of Krishnamoorthy et al would have been obvious to one of ordinary skill in the art at the time the invention was made.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to William T. Leader whose telephone number is 571-272-1245. The examiner can normally be reached on Mondays-Thursdays and alternate Fridays, 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Roy King, can be reached on 571-272-1244. The fax phone

Art Unit: 1742

number for the organization where this application or proceeding is assigned is 703-

872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

William Leader March 15, 2005

ROY KING SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 1700